

Chip Scale Review®

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The Future of Semiconductor Packaging

2018 Editorial Calendar

(Editorial close date: 6/15)

July • August

* indicates show distribution

High reliability materials

Metal-based wafer-level and 3D printed packaging

Temporary bonding for high temperature processing of thin glass

Chip-package-board co-design

Coaxial socket technology

Testing RF devices

Large-area fan-out processing

• **ICEPT 2018**

Shanghai, China (Aug 8-11)

• **SEMICON Taiwan ***

Taipei, Taiwan (Sept 5-7)

• **European MEMS & Sensors Summit**

Grenoble, France (Sept 19-21)

• **European Imaging & Sensors Summit**

Grenoble, France (Sept 19-21)

• **Strategic Materials Conference - SMC**

San Jose, CA (Sept 24-26)

International Directory of Wafer Probers & Probe Cards

Ad Space Close Jun 30 - Ad Materials Close Jul 7

(Editorial close date: 7/20)

September • October

* indicates show distribution

Effective, Scalable EMI Protection

Embedded RDL

High density flip-chip and advanced CSP

High-resolution 3D X-ray metrology

Advanced substrates and embedded packaging

High density advanced packaging (HDAP) design

Direct-placement process for LED's

Inspection strategies

High density advanced packaging design

• **SMTA International ***

Rosemont, IL (October 14-18)

• **IWLPC-International Wafer-Level Packaging Conference & Exhibition ***

San Jose, CA (Oct 23-25)

• **TestConX China 2018**

Suzhou, China (Oct 23)

Shenzhen, China (Oct 25)

• **MEMS & Sensors Executive Congress**

Napa, CA (Oct 28-30)

• **International Test Conference (ITC)**

Phoenix, AZ (Oct 31- Nov 2)

• **SEMI International Technology Partners Conference (ITPC)**

Maui, Hawaii (Nov 4-7)

• **SEMICON Europa**

Munich, Germany (Nov 13-16)

International Directory of Defect Inspection Systems

Ad Space Close Sep 8 - Ad Materials Close Sep 15

(Editorial close date: 9/21)

November • December

* indicates show distribution

5G developments

Cooling solutions for hi-density chips

Burn-in system technology advancements

Advanced eWLB for mmWave applications

Package assembly design kits

Collective bonding for heterogeneous integration

Lithography

Photonics for next generation applications

Robust interconnects for MEMS sensors

Wafer bumping

• **EPTC 2018 ***

Singapore (Dec 4-7)

• **MEPTEC: Heterogeneous Integration Symposium**

Milpitas, CA (Dec 5)

• **SEMICON Japan**

Tokyo, Japan (Dec 12-14)

• **SEMI European 3D Summit ***

Dresden, Germany (Jan 22-24, 2019)

• **SEMICON Korea**

Coex, Seoul, Korea (Jan 23-25, 2019)

Ad Space Close Nov 3 - Materials Close Nov 10

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Notes: Editorial calendar topics and distribution are subject to change without notice and are contingent on logistics and magazine production.
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